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S&H Form: (2/01)
Attorney Docket No. 300.1147

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Masatoshi AKAGAWA, et al.

Application No.: 10/790,872

Group Art Unit: 2853

Confirmation No.: 3133

Filed: March 3, 2004

Examiner: Lam S. Nguyen

For: PATTERN DRAWING APPARATUS AND PATTERN DRAWING METHOD FOR FORMING PATTERNS, THAT HAVE MIRROR IMAGE RELATIONSHIP TO EACH OTHER WITH RESPECT TO A SUBSTRATE, ON BOTH SIDES OF THE SUBSTRATE, AND TEST APPARATUS FOR USE IN THE PATTERN DRAWING APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 8, 2006, applicants elect Species I (Figs. 4-5) on which claims 1-9, 15-25 and 33-36 read, without traverse.

Respectfully submitted,

STAAS & HALSEY LLP

Date:

June 30, 2006

By:

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